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**IN THE
UNITED STATES
PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: Kirchner, et al.

SERIAL NO.: 10/815,116

FILED ON: March 31, 2004

DOCKET NO.: OST-041134

CUSTOMER NO.: 22876

RESPONSE TO FINAL
OFFICE ACTION

CONFIRMATION NO.: 6567

FOR: METHOD FOR DISTORTION
CORRECTION IN A
MICROLITHOGRAPHIC
PROJECTION EXPOSURE
APPARATUS

Box AF
COMMISSIONER
FOR PATENTS
P.O. Box 1450
Alexandria VA 22313-1450

ATTENTION OF: Art Unit 2851

EXAMINER: Gutierrez, Kevin C.

Dear Examiner:

In response to the Final Office Action of March 17, 2005, please consider the following:

Amendments to the Claims are reflected in the listing that begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.

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